THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Takatoshi Tsujimura et al.

Art Unit:

1762

Serial No.:

10/693,244

§ Examiner:

David P. Turocy

Filed:

October 24, 2003

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For:

Forming a Thin Film Structure

Atty. Dkt. No.:

CMO.0012US (92096US)

## **Mail Stop RCE**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## REPLY TO OFFICE ACTION MAILED JANUARY 9, 2006

Dear Sir:

In response to the Office Action mailed January 9, 2006, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.

Date of Deposit

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313.

Ginger Yount